

Notice of References Cited

Application/Control No.

10/004,714

Applicant(s)/Patent Under
Reexamination
MEIKLE ET AL.

Examiner

Ginette Peralta

Art Unit

2814

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf, Stanley; Silicon Processing for the VLSI Era, Volume 2: Process Integration, 1990. Lattice Press, Pages 609-615.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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